



MS AMENDMENT
PATENT
3430-0149P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Jeong-Jin KIM et al. Conf. No.: 5548
Appl. No.: 09/727,516 Group: 1765
Filed: December 4, 2000 Examiner: A. K. ALANKO
For: METHOD OF ETCHING AND CLEANING OBJECTS (As Amended)

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Office Action dated March 24, 2005, the response for which having been extended one (1) month to July 24, 2005, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

This reply includes

Amendments to the Specification;

Amended Claim Set; and

Remarks.